



Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 30-5000-(4015)-Div2	SERIAL NO. 09/784,233
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Shozo Nagano et al. #20	
				FILING DATE February 14, 2001	GROUP 1742

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
3	AA	5,312,790	05-1994	Sengupta et al.	501	137	
1	AB	5,435,826	07-1995	Sakakibara et al.	75	232	
	AC	5,486,491	01-1996	Sengupta	501	137	
2	AD	6,478,902 B2	11-2002	Koenigsmann et al.	148	681	
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
3	AL	11323539	11-1999	Japan		abstract	
2	AM	0441408A2	08-1991	EPO			
	AN						
	AO						
	AP						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
3	AR		Yeon et al., "Electrical Characteristics of the MOD-derived SrBi ₂ xTa ₂ O ₉ and SrBi ₂ .4(Ta,Nb) ₂ O ₉ Thin Films", Journal of Materials Science, 35(10), pgs. 2405-2411, May 15, 2000. Abstract only.
2	AS		Yan et al., "Preparation on the [(Pb,Lu) (Zr,Ti)O ₃] Ferroelectric Thin Films by Using the Sol-Gel Processing", Piezoelectrics and Acoustooptics, Volume 17, issue n 5, October 1995, pgs. 24-27.
	AT		

EXAMINER S Ie	DATE CONSIDERED 6/14/03
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.